

400 Garden City Plaza  
Garden City, New York 11530  
(516) 742-4343 - Telephone  
(516) 742-4366 - Facsimile  
e-mail: intprop@ssmp.com

**SCULLY, SCOTT, MURPHY  
& PRESSER**

**RECEIVED  
CENTRAL FAX CENTER**

MAR 15 2004

**Fax**

**OFFICIAL**

**To:** Examiner Monica Lewis

**From:** Leslie S. Szivos

**Fax:** 703-872-9306

**Pages:** 8 pages including cover sheet

**Phone:**

**Date:** 3/15/04

**Re:** U.S. Serial No. 09/862,827

**CC:**

Group Art Unit: 2822

Docket No. FIS920000224US2 (13814A)

## **RESPONSE UNDER 37 C.F.R. § 1.116**

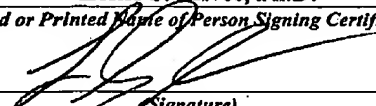
**• Comments:**

Attached hereto:

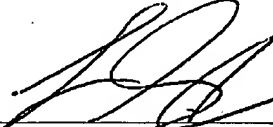
1. Amendment Transmittal Letter (in duplicate)
2. Response Under 37 C.F.R. § 1.116
3. Certificate of Transmission by Facsimile, dated March 15, 2004 (in duplicate)

**CONFIDENTIALITY:** The documents accompanying this facsimile transmission may contain information which is either confidential or legally privileged and is intended only for the authorized use of the individual or entity named above without right or publication or republication, dissemination or disclosure except as expressly set forth or established by course of dealing. All rights are reserved. If you are not the intended recipient, you are hereby notified that any disclosure, copying, distribution or use of the contents of this facsimile is prohibited. If you received this transmission in error, please notify us immediately by telephone to arrange for return of the documents.

If you have any problems concerning this facsimile, please call (516) 742-4343 and ask for Krista Croce..

<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>			<b>Docket No.</b>
Applicant(s): Jack A. Mandelman, et al.			FIS920000224US2 (13814A)
<b>Serial No.</b> 09/862,827	<b>Filing Date</b> May 22, 2001	<b>Examiner</b> Monica Lewis	<b>Group Art Unit</b> 2822
Invention: <b>METHOD FOR FORMING DUAL WORKFUNCTION HIGH-PERFORMANCE SUPPORT MOSFETs IN EDAM ARRAYS</b>			
<p>I hereby certify that this <u>                    <b>RESPONSE UNDER 37 C.F.R. § 1.116</b>                    </u> <i>(Identify type of correspondence)</i></p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)</p> <p>on <u>March 15, 2004</u> <i>(Date)</i></p> <p style="text-align: center;"><u>Leslie S. Szivos, Ph.D.</u> <i>(Typed or Printed Name of Person Signing Certificate)</i></p> <p style="text-align: center;"> <i>(Signature)</i></p> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>			

P18/REV01

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b>				<b>Docket No.</b> FIS920000224US2 (13814A)	
Applicant(s): Jack A. Mandelman, et al.					
Serial No. 09/862,827	Filing Date May 22, 2001	Examiner Monica Lewis	Group Art Unit 2822		
Invention: <b>METHOD FOR FORMING DUAL WORKFUNCTION HIGH-PERFORMANCE SUPPORT MOSFETs IN EDRAM ARRAYS</b>					
<u>TO THE COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	4 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>					<b>\$0.00</b>
 <input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. <b>09-0458/IBM</b> <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.  <div style="display:flex; justify-content:space-between; align-items:flex-end;"><div style="text-align:center;"> _____ <i>Signature</i></div><div>Dated: <b>March 15, 2004</b></div></div> <div style="display:flex; justify-content:space-between; margin-top:20px;"><div><b>Leslie S. Szivos, Ph.D.</b> Registration No. 39,394  <b>SCULLY, SCOTT, MURPHY &amp; PRESSER</b> 400 Garden City Plaza Garden City, New York 11530 (516) 742-4343</div><div style="border:1px solid black; padding:5px; width:40%; text-align:center;"><div><input checked="" type="checkbox"/> certify that this document and fee is being deposited on <b>3/15/04</b> with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</div><div>_____ <i>Signature of Person Mailing Correspondence</i></div><div><b>Leslie S. Szivos, Ph.D.</b></div><div>_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></div></div></div> <div>CC:</div>					

P111LARGE/REV06

MAR 15 2004

OFFICIAL

RESPONSE UNDER 37 C.F.R.  
§ 1.116 EXPEDITED PROCEDURE  
EXAMINING GROUP 2822**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Jack A. Mandelman, et al. Examiner: Monica Lewis  
Serial No: 09/862,827 Art Unit: 2822  
Filed: May 22, 2001 Docket: FIS920000224US2 (13814A)  
For: METHOD FOR FORMING DUAL Date: March 15, 2004  
WORKFUNCTION HIGH-PERFORMANCE  
SUPPORT MOSFETs IN EDRAM ARRAYS

Confirmation No.: 9621

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**RESPONSE UNDER 37 C.F.R. § 1.116**

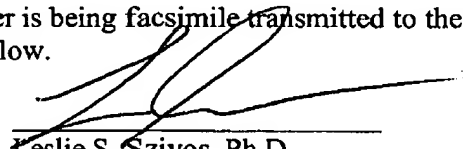
Sir:

In response to the Final Rejection dated January 14, 2004, applicants respectfully request that the following amendments and remarks be entered as of record in the above-identified patent application.

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: March 15, 2004

  
Leslie S. Szivos, Ph.D.

G:\Ibm\1111\13814a\amend\13814A.AM6.DOC